

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants:	Yeo, <i>et al.</i>	Docket No.:	TSM03-0926
Serial No.:	10/685,938	Art Unit:	2891
Filed:	October 15, 2003	Examiner:	Movva, Amar
For:	Dummy Pattern for Silicide Gate Electrode		

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT**

Dear Sir:

The following amendments and remarks are presented in response to the Examiner's Office Action mailed October 11, 2007. Please amend the above-referenced application as follows.